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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/955,512	09/17/2001	H.S. Lan	67,200-422	1813
75	590 10/05/2004		EXAM	INER
TUNG & ASSOCIATES			LOWE, MICHAEL S	
Suite 120 838 W. Long L	Suite 120 838 W. Long Lake Road ART UNIT		ART UNIT	PAPER NUMBER
Bloomfield Hills, MI 48302			3652	
			DATE MAILED: 10/05/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

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\bigwedge	Application No.	Applicant(s)	
Office Action Summary	09/955,512	LAN ET AL.	
Onice Action Summary	Examiner	Art Unit	144
The SAAU INC DATE of this commission is also	M. Scott Lowe	3652	L MU
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the o	orrespondence ac	ddress °
A SHORTENED STATUTORY PERIOD FOR REPL' THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a repl' - If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be tir y within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from , cause the application to become ABANDONE	nely filed vs will be considered time the mailing date of this of ED (35 U.S.C. § 133).	
Status			
Responsive to communication(s) filed on <u>02 July</u> This action is FINAL . 2b)⊠ This Since this application is in condition for alloware closed in accordance with the practice under E	action is non-final. nce except for formal matters, pro		e merits is
Disposition of Claims			
4)	wn from consideration.		
Application Papers			
9) ☐ The specification is objected to by the Examine 10) ☑ The drawing(s) filed on 17 September 2001 is/a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) ☐ The oath or declaration is objected to by the Example 11.	are: a)⊠ accepted or b)⊡ object drawing(s) be held in abeyance. Se tion is required if the drawing(s) is ob	e 37 CFR 1.85(a). ejected to. See 37 C	FR 1.121(d).
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicat rity documents have been receive u (PCT Rule 17.2(a)).	ion No ed in this National	l Stage
Attachment(s)	_		
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:	ate	O-152)

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In view of the arguments filed on 7/2/04, PROSECUTION IS HEREBY REOPENED. A new non-final rejection is set forth below.

To avoid abandonment of the application, appellant must exercise one of the following two options:

- (1) file a reply under 37 CFR 1.111 (if this Office action is non-final) or a reply under 37 CFR 1.113 (if this Office action is final); or,
 - (2) request reinstatement of the appeal.

If reinstatement of the appeal is requested, such request must be accompanied by a supplemental appeal brief, but no new amendments, affidavits (37 CFR 1.130, 1.131 or 1.132) or other evidence are permitted. See 37 CFR 1.193(b)(2).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-3,5,9,11,12,15,17, are rejected under 35 U.S.C. 103(a) as being unpatentable over Cheng (US 6,053,688) in view of Ohntrup (US 3,672,470).

Re claims 1,11, Cheng teaches a loadport equipped with automatic height adjustment means comprising:

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a movable platform 112 adapted for carrying a wafer cassette 16 thereon and for moving vertically in an up-and-down direction;

at least two support members 111,113 (or 128, 125) for supporting said movable platform and for moving said platform in an up-and-down direction.

Cheng is silent as to how the platform is controlled other than stating a computer or various equivalents may be used. However, Ohntrup teaches a load handling platform 16 that moves up and down to deliver containers using a distance sensor L mounted on a bottom surface (figure 3) of said movable platform for measuring a height of said movable platform (column 6, line 13) and a process controller (figure 8) for receiving a first signal from said distance sensor, comparing (determining a deviation) to a pre-stored datum D and then sending a second signal to said at least two support members move said movable platform until said first signal equals said pre-stored datum D in order to provide a simple, effective and versatile means for material handling (column 1, lines 56-57).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to have modified Cheng by the general teaching of Ohntrup to have a distance sensor mounted on a bottom surface of said movable platform for measuring a height of said movable platform and a process controller for receiving a first signal from said distance sensor, comparing (determining a deviation) to a pre-stored datum and then sending a second signal to said at least two support members move said movable platform until said first signal

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equals said pre-stored datum D in order to provide a simple, effective and versatile means for material handling.

Re claim 2, Cheng teaches the platform being a load port platform.

Re claims 3, 12,17, Cheng teaches said at least two support members are two support members spaced-apart each for supporting one of two ends of said movable platform.

Re claim 5, Cheng teaches said at least two support members further comprises a screw and a screw rail operated by a motor for moving said movable platform in an up-and-down direction (column 5, lines 51-58).

Re claims 9,15, Cheng as already modified teaches a general distance sensor. Ohntrup teaches an optical distance sensor since it is simple and effective (column 1, lines 56-57). It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Cheng to have an optical distance sensor since it is simple and effective.

Claims 7,8,10,14,16,19,20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Cheng (US 6,053,688) and Ohntrup (US 3,672,470) in view of Schauer (US 6,763,281).

Re claims 7,8,14, although Cheng as already modified by Ohntrup teaches a sensor that is used to level said platform, the sensor is not on or adjacent a top surface of the platform. Schauer teaches a leveling sensor on top of a platform order ensure that the system is aligned and prevent collisions

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(abstract). It would have been obvious to one of ordinary skill in the art at the time the invention was made to have modified Cheng by the general teaching of Schauer to have a leveling sensor on top of a platform order ensure that the system is aligned and prevent collisions.

Re claims 10,16,19,20 Cheng as already modified teaches a general distance sensor. Schauer teaches a sonic distance sensor (column 29, line 5) and other non-contact distance sensors are equivalent and more accurate than mechanical sensors (column 3). It would have been obvious to one of ordinary skill in the art at the time the invention was made to have modified Cheng general teaching of Schauer to have a sonic or other (infrared, ultrasonic,etc.) type of non-mechanical distance sensor in order to a functional equivalent sensor that is more accurate than mechanical sensors.

Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Carney (US 6,652,015) teaches an infrared distance sensor.

Motsenbocker (US 6,571,722) teaches ultrasonic distance sensors.

Hansen (US 5,201,626) teaches ultrasonic distance sensors.

Kato (US 2001/0016990) teaches height sensor for a carriage platform.

Hine (US 6,591,160) teaches a sonic distance sensor.

Anderson (US 6,059,511) teaches platform height (distance) sensors and a look-up table for controlling deviations.

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Wen (US 6,206,441) teaches distance sensors on the top and bottom of a platform.

Huang (US 6,060,721) teaches a cassette platform with distance sensor controls.

Nogami (US 4,759,681) teaches a cassette platform with distance sensor controls.

Fukui (US 5,438,418) teaches a cassette platform with distance sensor controls.

Kato (US 6,208,909) teaches a cassette platform with distance sensor controls (figure 8).

Regarding applicants argument that Cheng does not teach a load port, however Cheng states that the invention does have loadport 10,100 for semiconductor fabrication equipment.

Applicant's remaining arguments with respect to claims have been considered but are most in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Scott Lowe whose telephone number is 703-305-1940. The examiner can normally be reached on 6:30am-4:30pm M,Tu,Th,F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eileen Lillis can be reached on 703-308-3248. The fax

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phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

msl

EILEEN D. LILLIS SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 3600

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